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10/805,039	03/19/2004	Kenneth Allen Poppleton	144021	7963
75	90 11/09/2005		EXAMINER	
Dean D. Small			SUCHECKI, KRYSTYNA	
Armstrong Teasdale LLP Suite 2600			ART UNIT PAPER NUMBER	
One Metropolitan Square			2882	
St. Louis, MO 63102			DATE MAILED: 11/09/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)	
Office Action Commence	10/805,039	POPPLETON, KENNETH	ALLEN
Office Action Summary	Examiner	Art Unit	
	Krystyna Suchecki	2882	
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the c	orrespondence address -	-
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING D/ - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period v - Failure to reply within the set or extended period for reply will, by statute. Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tim will apply and will expire SIX (6) MONTHS from the cause the application to become ABANDONE	N. nely filed the mailing date of this communica D (35 U.S.C. § 133).	·
Status			
1) Responsive to communication(s) filed on <u>23 A</u> an <u>23 A</u> an <u>25 Disconsisted</u> This action is FINAL . 2b Disconsisted This	ugust 2005. action is non-final.		
3) Since this application is in condition for allowar		secution as to the merits	is
closed in accordance with the practice under E			
Disposition of Claims			
4) Claim(s) 1-22 is/are pending in the application. 4a) Of the above claim(s) is/are withdray 5) Claim(s) is/are allowed. 6) Claim(s) 1-22 is/are rejected. 7) Claim(s) is/are objected to. 8) Claim(s) are subject to restriction and/or	vn from consideration.		
Application Papers			
 9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) access applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Examine 	epted or b) objected to by the Edrawing(s) be held in abeyance. See ion is required if the drawing(s) is obj	e 37 CFR 1.85(a). ected to. See 37 CFR 1.12	` '
Priority under 35 U.S.C. § 119			
 12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the prior application from the International Bureau * See the attached detailed Office action for a list of the certified copies of the certified copies 	s have been received. s have been received in Application rity documents have been received u (PCT Rule 17.2(a)).	on No ed in this National Stage	
Attachment(s) Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:		

DETAILED ACTION

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1-3, 5-10, 12 and 14-18 are rejected under 35 U.S.C. 102(e) as being anticipated by Koch (US 6,960,879).

Regarding Claim 1, Koch teaches a method for calibrating an X-ray imaging system, said method comprising: configuring an output of a calibration image source (Figure 3) in a pattern (provided by grating, 23) to define a calibration image: generating a calibration image within an X-ray imaging system using the calibration image source; and determining an image distortion of the X-ray imaging system based upon the calibration image for calibrating the X-ray imaging system (Figure 1 and Column 4, lines 43-57).

Regarding claim 2, Koch teaches a method in accordance with claim 1 further comprising calibrating the X-ray imaging system using the calibration image (Column 4, lines 43-57).

Regarding Claim 3, Koch teaches a method in accordance with claim 2 wherein the calibrating is performed after one of determining a change in an external source

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causing distortion and moving the X-ray imaging system (Column 1, lines 48-62 and Column 4, lines 3-7).

Regarding Claims 5, 10 and 12, Koch teaches a method in accordance with claim 1 further comprising measuring an output image generated based upon the calibration image to determine the image distortion or comprising comparing the calibration image to an output image to determine and compensate for the image distortion (Column 1, lines 35-47 and Column 4, lines 43-65).

Regarding Claims 6-9, Koch teaches a method in accordance with claim 1 wherein the calibration image comprises a pattern comprising one of a grid, a plurality of dots and a pattern of shapes by generating a light pattern, which is a non-x-ray pattern (Column 3, lines 51-67).

Regarding Claim 14, Koch teaches a method for determining distortion in an X-ray imaging system, said method comprising: generating a light pattern at an output of a calibration image source within an image intensifier of an X-ray imaging system (Figure 3); comparing an output produced by the image intensifier to the light pattern output of the calibration image source; and determining a distortion based upon the comparison (Column 1, lines 35-47 and Column 4, lines 43-65).

Regarding Claim 15, Koch teaches a method in accordance with claim 14 further comprising compensating for the distortion (Column 1, lines 35-47 and Column 4, lines 43-65).

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Regarding Claim 16, Koch teaches a method in accordance with claim 14 wherein the light pattern comprises one of a measurable and identifiable pattern (Column 3, lines 51-67).

Regarding Claim 17, Koch teaches a method in accordance with claim 14 wherein the image intensifier comprises a calibration image source having at least one laser light source for generating the light pattern (Column 3, lines 40-50).

Regarding Claim 18, Koch teaches a method in accordance with claim 17 wherein the laser light source comprises a grating (23) for creating the light pattern.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 4, 13 and 19-22 are rejected under 35 U.S.C. 103(a) as being unpatentable over Koch in view of Quadflieg (US 6,086,252).

Regarding Claims 4, 13, 19 and 21, Koch teaches an image intensifier method as above for claims 1 and 14, and thereby teaches a system for determining distortion within an X-ray imaging device.

Koch fails to teach the generating as performed within the image intensifier by a calibration image source within an image intensifier for generating the calibration image within the image intensifier, the calibration image source positioned within the image

intensifier generally at an end of the image intensifier that is closer to an output window than to an input window.

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Quadflieg teaches light sources positioned within the image intensifier generally at an end of the image intensifier that is closer to an output window than to an input window (4) for noise correction in an image intensifier (Figure 1). An obvious benefit of containing the light sources within the image intensifier is that the light sources cannot be bumped or smashed while moving the image intensifier, since they are contained inside and thereby protected.

Therefor, it would have been obvious to one of ordinary skill in the art at the time the invention was made to house the calibration image source of Koch within the image intensifier housing as taught by Quadflieg since the containment of the image source within the image intensifier would offer protection from bumping and smashing while moving the image intensifier.

Regarding Claim 20, Koch teaches a system in accordance with claim 19 wherein the calibration image comprises a pattern (Column 3, lines 51-67).

Regarding Claim 22, Koch teaches a system in accordance with claim 19 wherein the X-ray imaging system comprises a mobile X-ray imaging system (Column 1, lines 48-62 and Column 4, lines 2-7).

Claim 11 is rejected under 35 U.S.C. 103(a) as being unpatentable over Koch in view of Pradere.

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Regarding Claim 11, Koch teaches image distortion correction for a mobile X-ray imaging system as above for claims 1, 3 and 10.

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Koch fails to teach calibration as performed in connection with a mobile X-ray imaging system to compensate for changes in non-uniform magnetic fields

Pradere teaches calibration is performed in image intensifier systems in connection with a mobile X-ray imaging system to compensate for changes in non-uniform magnetic fields (Column 3, lines 1-14, and via motion between magnetic isolation and patient testing areas, Column 6, line 66- Column 7, line 34). Such calibration addresses deleterious S deformation (Column 1, lines 50-65).

Therefor, it would have been obvious to one of ordinary skill in the art at the time the invention was made to compensate for changes in non-uniform magnetic fields in the method of Koch as taught by Pradere in order to address deleterious S deformation (Pradere, Column 1, lines 50-65).

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the

shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Krystyna Suchecki whose telephone number is (571) 272-2495. The examiner can normally be reached on M-F, 9-5.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Edward Glick can be reached on (571) 272-2490. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

W_{ks}

Craig E. Church Primary Examiner

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